(12) INTERNATIONAL APPLICATION PUBLISHED UNDER THE PATENT COOPERATION TREATY (PCT)

(19) World Intellectual Property Organization International Bureau





(43) International Publication Date 24 December 2003 (24.12.2003)

PCT

(10) International Publication Number WO 03/105685 A2

(51) International Patent Classification7:

(21) International Application Number:

PCT/IT03/00366

A61B 5/00

(22) International Filing Date:

12 June 2003 (12.06.2003)

(25) Filing Language:

Italian

(26) Publication Language:

English

(30) Priority Data:

TO2002A000515

14 June 2002 (14.06.2002) I'

- (71) Applicant (for all designated States except US): INFM ISTITUTO NAZIONALE PER LA FISICA DELLA MATERIA [IT/IT]; Cordo F. Perrone, 24, I-16152 Genova (IT).
- (72) Inventors; and
- (75) Inventors/Applicants (for US only): DI FABRIZIO, Enzo [IT/IT]; Via dei Crociferi 2, I-34124 Trieste (IT). CABRINI, Stefano [IT/IT]; Via Carlo Alberto Dalla Chiesa 8, I-00061 Anguillara Sabazia (IT). COJOC, Danut, Adrian [RO/IT]; Via Damiano Chiesa 115, I-34128 Trieste (IT). BUSINARO, Luca [IT/IT]; Via San Giorgio 2, I-34123 Trieste (IT).

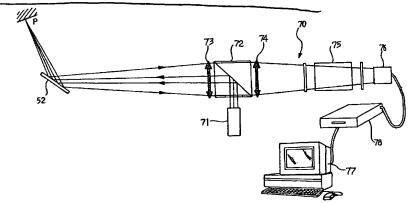
- (74) Agents: RAMBELLI, Paolo et al.; Jacobacci & Partners SpA, Corso Regio Parco, 27, I-10152 Torino (IT).
- (81) Designated States (national): AE, AG, AL, AM, AT, AU, AZ, BA, BB, BG, BR, BY, BZ, CA, CH, CN, CO, CR, CU, CZ, DE, DK, DM, DZ, EC, EE, ES, FI, GB, GD, GE, GH, GM, HR, HU, ID, IL, IN, IS, JP, KE, KG, KP, KR, KZ, LC, LK, LR, LS, LT, LU, LV, MA, MD, MG, MK, MN, MW, MX, MZ, NI, NO, NZ, OM, PH, PL, PT, RO, RU, SC, SD, SE, SG, SK, SL, TJ, TM, TN, TR, TT, TZ, UA, UG, US, UZ, VC, VN, YU, ZA, ZM, ZW.
- (84) Designated States (regional): ARIPO patent (GH, GM, KE, LS, MW, MZ, SD, SL, SZ, TZ, UG, ZM, ZW), Eurasian patent (AM, AZ, BY, KG, KZ, MD, RU, TJ, TM), European patent (AT, BE, BG, CH, CY, CZ, DE, DK, EE, ES, FI, FR, GB, GR, HU, IE, IT, LU, MC, NL, PT, RO, SE, SI, SK, TR), OAPI patent (BF, BJ, CF, CG, CI, CM, GA, GN, GQ, GW, ML, MR, NE, SN, TD, TG).

Declarations under Rule 4.17:

— as to applicant's entitlement to apply for and be granted a patent (Rule 4.17(ii)) for the following designations AE, AG, AL, AM, AT, AU, AZ, BA, BB, BG, BR, BY, BZ, CA, CH, CN, CO, CR, CU, CZ, DE, DK, DM, DZ, EC, EE, ES, FI, GB, GD, GE, GH, GM, HR, HU, ID, IL, IN, IS, JP, KE, KG, KP, KR, KZ, LC, LK, LR, LS, LT, LU, LV, MA, MD, MG, MK,

[Continued on next page]

(54) Title: AN APPARATUS FOR DETERMINING THE INTERNAL OUTLINE OF A DUCT OR CAVITY, AND IN PARTICULAR-FOR-DETERMINING THE INTERNAL IMPRESSION OF THE AUDITORY CANAL, A PROBE FOR THIS APPARATUS, AND A REFLECTION DEVICE FOR AN OPTICAL SCANNING APPARATUS



3/105685

(57) Abstract: An apparatus for determining the internal outline of a duct or cavity, comprises light-emitting means (71) suitable for generating a collimated light beam, an elongate probe element (51; 51'; 51") suitable for being introduced into the duct and for guiding the collimated beam along a predetermined propagation direction, reflector means (52) supported by the probe element (51; 51'; 51") and suitable for deflecting the collimated beam so as to illuminate the internal wall of the duct, and for deflecting the reflected or diffused light coming from an illuminated point (p) of the internal wall so as to guide it along the probe element (51; 51'; 51"), and detection means (76) suitable for receiving an image of the illuminated point (p), which image is correlated with the optical distance of the point from the detection means (76), and for providing a corresponding electrical signal. The image is formed by the light guided by the receiving reflector means (52). The reflector means comprise a micro-mirror element (52) articulated to a distal end of the probe element (51; 51'; 51"). The micro-mirror element (52) is orientable so as to deflect the collimated beam in selectively different directions.

WO 03/105685 A2



MN, MW, MX, MZ, NI, NO, NZ, OM, PH, PL, PT, RO, RU, SC, SD, SE, SG, SK, SL, TJ, TM, TN, TR, TT, TZ, UA, UG, UZ, VC, VN, YU, ZA, ZM, ZW, ARIPO patent (GH, GM, KE, LS, MW, MZ, SD, SL, SZ, TZ, UG, ZM, ZW), Eurasian patent (AM, AZ, BY, KG, KZ, MD, RU, TJ, TM), European patent (AT, BE, BG, CH, CY, CZ, DE, DK, EE, ES, FI, FR, GB, GR, HU, IE, IT, LU, MC, NL, PT, RO, SE, SI, SK, TR), OAPI patent (BF, BJ, CF, CG, CI, CM, GA, GN, GQ, GW, ML, MR, NE, SN, TD, TG)

— of inventorship (Rule 4.17(iv)) for US only

Published:

 without international search report and to be republished upon receipt of that report

For two-letter codes and other abbreviations, refer to the "Guidance Notes on Codes and Abbreviations" appearing at the beginning of each regular issue of the PCT Gazette.

An apparatus for determining the internal outline of a duct or cavity, and in particular for determining the internal impression of the auditory canal, a probe for this apparatus, and a reflection device for an optical scanning apparatus

The present invention relates to an apparatus for determining the internal outline of a duct or cavity and, in particular, to an apparatus for determining the internal impression of the auditory canal.

It is known that modern internal hearing prostheses have to fit the shape of the user's auditory canal as well as possible. For this purpose, it is necessary to have an accurate copy of the internal impression of the auditory canal. According to conventional techniques, this is achieved by introducing quick-setting mouldable material into the auditory canal. Once the material has set, it is removed from the ear, thus providing a cast of the canal. Finally, the surface of the cast is subjected to a scanning process and is mapped so as to produce data that can be stored by a computer.

For example, United Sates patent US 5,487,012 describes a method for the scanning of a cast of an auditory canal in order to obtain a digital image which is then processed in order to design the hearing prosthesis.

These conventional techniques for determining the internal profile of the auditory canal have some disadvantages, amongst which is their inevitable invasive nature and the complexity and number of steps that are necessary to produce a cast suitable for the manufacture of a mould for the preparation of the outer shell of the hearing prosthesis,

since the cast extracted from the ear has to be processed further in order to eliminate its imperfections.

describes an apparatus 02/091920 document WO The obtaining geometrical data relating to the internal surface of the ear, comprising a probe with a rod portion containing at least one light guide and a light source at the proximal The apparatus further comprises a end of the light guide. distal portion which can be inserted in the ear canal and has means for directing the light onto at least one point of the internal surface of the ear canal. For this purpose, the above-mentioned means comprise a mirror with a conical quite bulky and probe of this type is surface. A inefficient, particularly when the ear canal is tortuous.

An object of the invention is to provide an apparatus which can produce a three-dimensional image of the auditory canal automatically whilst avoiding contact of any type with the internal walls of the ear and facilitating the process of producing the final cast.

This object is achieved, according to the invention, by an apparatus for determining the internal outline of ducts and cavities, having the characteristics defined in the claims.

A further object of the present invention is to provide a probe for apparatus for determining the internal profile of ducts and cavities having the characteristics defined in the claims.

This object is achieved, according to the invention, by a probe having the characteristics defined in Claims 4 to 9.

As will be appreciated, although the apparatus according to the invention is particularly suitable for producing an internal impression of the auditory canal, it can be used to produce a three-dimensional map of the internal walls of ducts or cavities of small cross-section and, in particular, those which are quite inaccessible and which have constrictions or partial occlusions.

According to another object of the present invention, a reflection device for optical scanning apparatus having the characteristics defined in Claims 10 to 13 is proposed.

By virtue of greater lightness and flexibility in comparison with known devices (described, for example, in J. Micromech. Microeng. 13 (2003) 383-389), a device of this type is particularly suitable for use in the apparatus according to the invention.

According to another object of the present invention, a method of producing an internal impression of the auditory canal is proposed, this method having the characteristics defined in Claim 14.

According to a further object of the present invention, a method for the manufacture of internal hearing prostheses is proposed, this method having the characteristics defined in Claim 15.

Some preferred but non-limiting embodiments of the invention will now be described with reference to the appended drawings, in which:

Figure 1 is a perspective view of a probe for an apparatus for determining the internal outline of ducts and cavities according to the invention,

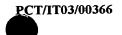


Figure 2 is a view showing a second embodiment of the probe of Figure 1 from above,

Figure 3 is a schematic view of an apparatus for determining the internal profile of ducts and cavities according to the invention,

Figure 4 is a diagram illustrating the operating principle of the apparatus of Figure 3,

Figure 5 is a perspective view of a third embodiment of the probe of Figure 1, and

Figure 6 is a view of a detail of the probe of Figure 5.

With reference to Figure 1, an apparatus for determining the internal profile of ducts and cavities comprises a probe unit 50 suitable for being introduced into the cavity of the The probe unit 50 comprises a probe duct to be measured. arm 51 formed by a rod of small dimensions suitable for supporting a substantially flat micro-mirror 52 by means of a microscopic lever 53. One end of the lever 53 is integral to the body of the micro-mirror 52 and a central portion of the lever is articulated to the distal end of the probe arm 51 by means of a microscopic pin 54. The free end of the lever 53 is connected magnetically to a control rod 55 which is arranged parallel to the probe arm 51 and can slide along its own longitudinal axis. The movement of the rod 55 is brought about by piezoelectric means (not shown) disposed at the proximal end of the rod 55.

The elements of the probe unit 50 are covered with a protective layer produced, for example, by evaporation of plastics materials.

In an apparatus for determining an internal impression of the auditory canal, the Applicant has produced a probe unit 50 of the type described above having a length of about 3 cm and a cross-section of about 2 mm diameter. These components were manufactured by known micromechanical and microlithographic techniques and the micro-mirror 52 was produced by nanolithography techniques.

The probe unit 50 is supported by a drive unit 60 which, with the use of known mechanisms, can move the probe unit 50 rigidly along the longitudinal axis of the probe arm 51 (indicated by the arrow A), can rotate it about the central axis of the optical system (in the direction indicated by the arrow B), and can move the control rod 55 alone along its longitudinal axis (in the direction of the arrow C). The movement of the control rod 55 moves the lever 53 which pivots about the pin 54, inclining the micro-mirror 52 in a plane containing the central axis X of the optical system (in the directions of the arrow D) which will be described below.

In a second embodiment of the invention, shown in Figure 2, controlled micro-mirror 52 is the orientation of the electromagnetically. A plurality of conductive tracks are deposited on a probe arm 51' of a type similar to that described above but made of insulating material. particular, a first control track and a second control track 61', 62' extend between respective contacts 63', 63'; 64', 64' on the proximal end of the arm 51', the tracks extending along substantially the entire length of the arm 51' and forming respective transverse portions 65', 66' distal end of the arm 51'. A central track 67' extends parallel to the tracks 61', 62', remaining interposed between them and extending between contacts 67a', 67a'. central track 67' forms a transverse portion 68' interposed between the transverse portions 65' and 66' of the control tracks 61', 62'. The micro-mirror 52 is formed integrally with the transverse portion 68'.

Beneath the micro-mirror 52, the probe arm 51' has an opening 69' which has a cross-section larger than that of the micro-mirror 52 and is arranged so as to encompass it completely.

The tracks 61', 62', 67' and the micro-mirror 52 are produced by conventional deposition techniques and the opening 69' is produced by chemical etching techniques, after the deposition of the micro-mirror 52.

The micro-mirror 52 enables the electrical continuity of the transverse portion 68' to be maintained and the portion 68' provides a pin about which the micro-mirror 52 can rotate freely in the opening 69'.

According to this embodiment of the invention, the drive unit 60 can orient the micro-mirror 52 by sending electrical currents to the tracks 61', 62', 67' via the contacts 63', 64' and 67a'. The direction of the currents in the transverse portions 65', 66', 68' determines the direction of rotation of the micro-mirror 52.

A control unit (not shown) controls the drive unit 50 and detects the position and the orientation of the movable elements of the probe unit 50.

With further reference to Figure 1, a light emitter and a light detector, generally indicated 70, can project a collimated light beam against the micro-mirror 52 and can receive the light reflected by the micro-mirror 52, respectively. The central axis X of the optical system is

formed by the straight line which joins the emitter/receiver 70 and the micro-mirror 52. In the condition in which the probe unit 50 is inserted in the duct, the light beam projected by the emitter/receiver 70 and reflected by the micro-mirror 52 falls on the internal walls of the duct or of the cavity. Each point struck by the light beam in turn reflects or diffuses the light. The light which is reflected or diffused along the line of incidence of the light beam reaches the mirror which reflects it towards the emitter/receiver 70.

With reference to Figure 3, this shows schematically the optical arrangement of the emitter/receiver 70. arrangement is based on conoscopic holography principles. It comprises an almost monochromatic light source 71, for example, a laser, which generates a light beam that is reflected by a semi-reflecting prism 72 and is projected, through an adaptation objective 73, towards the object to be measured, by reflection on the micro-mirror 52. returning reflected and diffused light re-enters through the adaptation objective 73, after being reflected again by the micro-mirror 52, passes through the semi-reflecting prism 72 and a shaping objective 74, finally reaching a conoscopic which can produce an interference pattern 75 indicative of the radial distance of the point of incidence This interference pattern is of the beam transmitted. detected by a CCD sensor 76 and transmitted to a processing unit 77 via an interface 78.

The structure and the principle of operation of the conoscopic module 75 will now be described briefly with reference to Figure 4. This structure comprises a pair of circular polarizers 75a, 75b between which a crystal (of length L) is interposed so as to produce an interference pattern.

Each object point P struck by the collimated beam (as shown in Figure 3) diffuses or reflects a non-polarized and spatially incoherent, almost monochromatic light. emerging from the point P at a generic angle β (where β , which is not indicated in the drawing, defines a generic direction of diffusion or reflection) relative to the axis of the optical system passes through the first circular polarizer 75a, which produces two perpendicularly polarized rays that are out of phase by 90°. Within the crystal 75c, the two rays are propagated in accordance with two modes, that is, the ordinary mode and the extraordinary mode, with different velocities (β_o and θ_o indicate the angle between the ordinary ray and the optical axis outside and inside the crystal 75c, respectively, and β_{e} and θ_{e} indicate the angle between the extraordinary ray and the optical axis outside and inside the crystal 75c, respectively). In a uniaxial crystal, the ordinary refraction index is constant, whereas the extraordinary refraction index depends on the angle θ_{e} between the ray and the optical axis of the crystal and hence on the location of the object point P. When the two rays emerge from the crystal 75c, they are out of phase in accordance with their velocity difference. When they pass through the second polarizer 75b, the two rays regain the same polarization mode. A conoscopic hologram is thus obtained by measuring the intensity of illumination at every point Q of the recording plane of the CCD sensor 76 (Z_c is intrinsic conoscopic distance, corresponding to the apparent distance between Q in the recording plane and the emission point P). This intensity distribution results from the interference between the ordinary and extraordinary rays. The resulting interference pattern, which is known as a Fresnel zone plate, may be constructive or destructive according to the phase difference of the two rays.

The interference pattern resulting from a point object consists of a set of concentric fringes with an inter-fringe distance which decreases radially outwards. The modulation in intensity I(Q) resulting from the interference between the ordinary and extraordinary rays at the point Q(x', y') is correlated with the intensity I(P) at the object point P(x,y,z) by the equation:

$$I(Q) = I(P)(1 + \cos \Delta \varphi) \tag{1}$$

where $\Delta \phi$ is the phase difference between ordinary ray and extraordinary ray. Since this phase difference is correlated with the distance of the point P from the recording plane of the CCD sensor 76, it is possible to measure the periods of the fringes of the holograms in order to determine the exact distance from the point measured.

The drive unit 60, controlled by the control unit, guides the translational and/or rotational movement of the probe unit 50 and/or the orientation of the micro-mirror 52, enabling the probe 50 to measure the optical distance of a predetermined quantity of points of the internal wall of the duct such as to enable the outline of the wall to be mapped with the desired accuracy.

A further embodiment of the present invention is illustrated in Figures 5 and 6. A probe unit 50" is supported by a drive unit (not shown) which is similar to the drive unit 60 described with reference to the embodiment of Figure 1 and which can move the probe unit 50" rigidly along its longitudinal axis and can rotate it about the central axis of the optical system contained in the probe unit 50" and described below.

A winding 61" of wire made of insulated conductive material, for example copper, is disposed on a probe arm preferably along its entire length, the probe arm being of similar type to those described above but of substantially cylindrical shape and made of ferromagnetic material. its distal end, the arm 51" comprises a support portion 51a" projecting outside the last turns of the winding 61". magnetically element 62 " of non-magnetic (orinsulating) material is fixed to the support portion 51a". formed by a self-supporting film of A micro-mirror 52, metallic material, is suspended in the centre of the frame element 62" and fixed to the frame element 62" by twisting central arms 63" made of the same material as the microin similar manner to the micro-mirror of mirror. The term "self-supporting" embodiment relating to Figure 2. means that the film can support itself without the aid of a supporting substrate.

If a current is caused to flow through the winding 61", the unit formed by the arm element 51" and by the winding 61" forms an electromagnet. By modulating the current flowing through the winding 61", it is thus possible to induce a variable magnetic field proportional to the current. vector of magnetic induction within the arm constitutes the core of the electromagnet) is constant and is directed along the axis X of the arm 51" (magnetic circuit). At the end of the electromagnet, that is, in the region of the distal end of the arm 51", the magnetic field is arranged as for a normal dipole. The micro-mirror 52 is disposed actually in the vicinity of the last turns of the winding 61", very close to the arm element 51". Since the micro-mirror 52 is made of ferromagnetic material, magnetic field which strikes it induces in it a magnetic polarization which subjects it to a force. This tends to cause the micro-mirror to rotate about the central arms 63",

WO 03/105685 PCT/IT03/00366

so as to align the induced dipole with the magnetic field lines, minimizing the energy of the system. As for the embodiment of Figure 2, this rotation is actually a twisting of the central arms 63" which produce a resilient biasing force that opposes the magnetic force and tends to return the mirror to the equilibrium position (magnetic field zero). The angle of rotation is controlled by modulating the intensity of the current which passes through the winding 61", that is, by altering the magnetic induction field. By changing the direction of the current, it is also possible to reverse the direction of rotation of the micromirror 52.

The manufacture of the micro-mirror/frame unit is based on a conventional micro-machining technique with the use of a This sacrificial layer enables normal sacrificial layer. optical lithography and electrolytic growth techniques to be used for the production of the device, finally offering the possibility of separating the device from the substrate, rendering it completely free-standing. Once separated from bar fixed of the device is on the substrate, the ferromagnetic material by one side of the frame.

The configuration of Figures 5 and 6 has the advantage, in comparison with the configuration of Figure 2, that the current does not pass through the micro-mirror 52 but only through the winding 61"; this reduces problems connected with the thermal stress of the mirror 52 (which may even be destroyed if too large a current passes through it) and thus permits the use of larger currents and consequently enables larger angles of rotation (possibly larger by several tens of degrees) to be achieved, whilst the average life of the device is much longer. Moreover, with this configuration, it is possible to select the ferromagnetic material of the arm 51" (and hence its magnetic permeability μ_r) and the

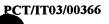
number of turns of the winding 61" in a manner such as to adapt the relationship between current and desired angle of rotation according to the required application.

12

The data relating to the measurements made with the probe units 50 are processed by the processing unit 77 so as to obtain the distances of the points measured, correlated with the images of these points received from the CCD sensors. The processing unit 77 reconstructs the outline of the internal wall of the duct measured with the use of conventional three-dimensional image management programs. This outline can easily be stored as a graphics file having, for example, a CAD format.

The three-dimensional representation obtained by the processing unit 77 can be used directly for the automatic control of the manufacture of a piece of hearing prosthesis.

be limited to the intended to invention is not The embodiments described and illustrated herein, which should be considered as examples of the apparatus for determining the internal outline of a duct or cavity and, in particular, for determining the internal impression of the auditory canal, and of the respective probe; rather, the invention may be modified with regard to shape and arrangements of parts, constructional details, and operation. For example, the distal end of the probe unit 50 may be provided with a proximity sensor which can detect a condition of excessive proximity of that end to the walls of the duct. the apparatus may be provided with a feeler device which can detect movements of the duct as a whole which is subjected to measurement so as to improve the accuracy of the mapping. The measurements taken would in fact be processed so as to these remove therefrom contributions that due to are These arrangements are particularly appropriate movements.



when the apparatus according to the invention is used to determine the internal impression of a patient's auditory canal.

CLAIMS

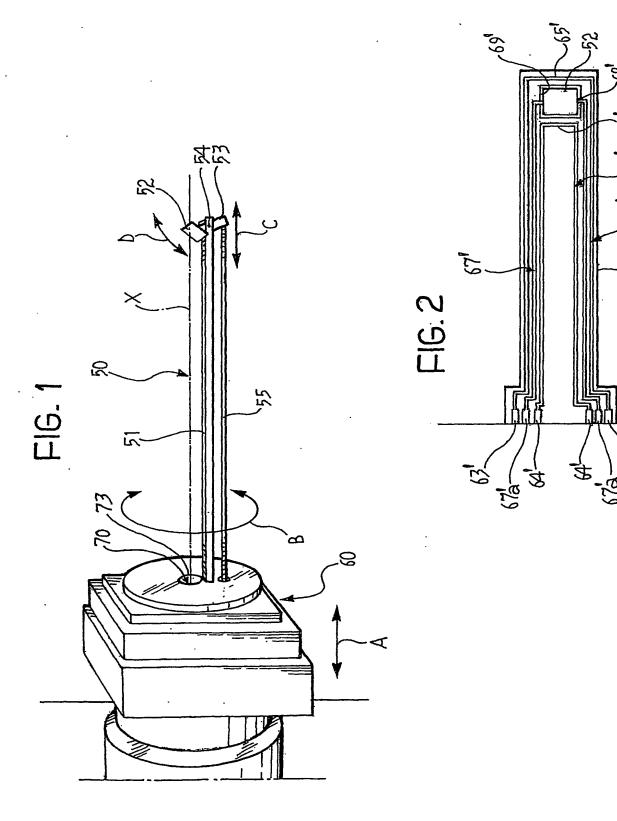
- 1. An apparatus for determining the internal outline of a duct or cavity, comprising:
- light-emitting means (71) suitable for generating a collimated light beam,
- an elongate probe element (51; 51'; 51") suitable for being introduced into the duct and for guiding the collimated beam along a predetermined propagation direction,
- reflector means (52) supported by the probe element (51;, 51'; 51") and suitable for deflecting the collimated beam so as to illuminate the internal wall of the duct, and for deflecting the reflected or diffused light coming from an illuminated point (P) of the internal wall so as to guide it along the probe element (51; 51'; 51"), and
- detection means (76) suitable for receiving an image of the illuminated point (P), which image is correlated with the optical distance of the point from the detection means (76), and for providing a corresponding electrical signal,
- characterized in that the reflector means comprise a micromirror element (52) articulated to a distal end of the probe element (51; 51'; 51"), the micro-mirror element (52) being orientable so as to deflect the collimated beam in selectively different directions.
- 2. An apparatus according to Claim 1, further comprising a drive unit (60) for moving the probe element (51; 51'; 51") and a unit (77) for processing the electrical signal, the drive unit and the processing unit cooperating so as to bring about mapping of the internal wall of the duct.

- 3. An apparatus according to Claim 2, comprising conoscope means (75) interposed between the receiving reflector means (52) and the detection means (76) and suitable for producing, with the light guided by the reflector means, a holographic image with concentric interference fringes which is detectable by the detection means (76), the periods of the fringes being correlated with the optical distance of the illuminated point (P).
- 4. A probe for an apparatus for determining the internal outline of a duct or cavity, comprising a probe arm element (51; 51'; 51") suitable for being introduced into the duct and supporting at its distal end a micro-mirror element (52) which can deflect a collimated light beam directed along the probe element (51; 51'; 51") so as to illuminate the internal wall of the duct, and which can deflect the reflected or diffused light coming from an illuminated point of the internal wall so as to guide it once more along the probe element (51; 51'; 51") to enable it to be received by detection means (76) of the apparatus, characterized in that the micro-mirror element is articulated to the probe arm element (51; 51'; 51") so as to be orientable in a radial plane relative to the probe arm element (51; 51'; 51").
 - 5. A probe according to Claim 4 in which the micro-mirror element (52) is integral to one end of a lever element (53) articulated to the distal end of the probe arm element (51), the free end of the lever element (53) being operable by a control rod element (55) which is arranged parallel to the probe arm element (51) and can translate along its longitudinal axis.
 - 6. A probe according to Claim 4 in which an electrical current can flow through the micro-mirror element (52) which is disposed between a pair of elongate conductor elements

- (65'; 66') suitable for bringing about rotation of the micro-mirror (52) as a result of the electrical currents passing through them.
- 7. A probe according to Claim 6 in which the elongate conductor elements (65'; 66') and the micro-mirror element (52) are produced by deposition on the probe arm element (51').
- 8. A probe according to Claim 5 in which the probe arm element (51") is made of ferromagnetic material and is wound up, along its length, by a winding (61") capable of conducting current, the micro-mirror element (52) also being made of ferromagnetic material, so that the rotation of the micro-mirror (52) is brought about by a magnetic field produced by the current passing through the winding (61").
- 9. A probe according to any one of Claims 5 to 8 in which the probe arm element (51; 51'; 51") can translate along its own longitudinal direction and can rotate about the direction of propagation of the collimated beam.
- 10. A reflection device for an optical scanning apparatus, comprising a frame element (69'; 62") which can support a substantially flat micro-mirror (52) connected to the frame element (69'; 62") by twisting arms (68'; 63") that are disposed on two opposite sides thereof, and a support element (51'; 51") which is connected rigidly to the frame element (69'; 62") and can support electromagnetic control means (61'; 62'; 67) for bringing about the rotation of the micro-mirror (52) about the twisting arms (68'; 63"), characterized in that the micro-mirror is formed by a self-supporting film of metallic material.

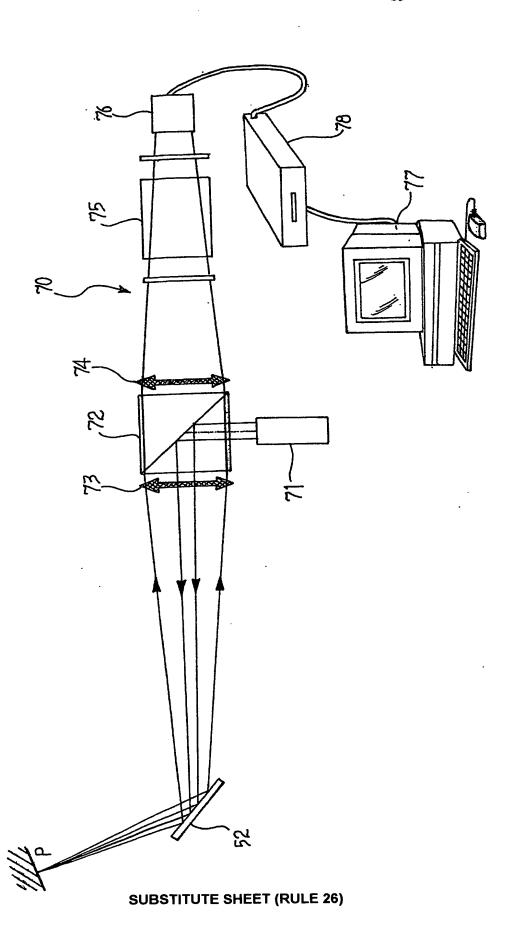
- 11. A device according to Claim 10 in which the frame element (69'; 62") is connected to the support element (51'; 51") at one end thereof.
- 12. A device according to Claim 10 or Claim 11, in which the electromagnetic control means comprise a conductive track (67') disposed on the support element (51') and connected to the micro-mirror (52) by means of the twisting arms (68'), and a pair of conductive control tracks (61'; 62') disposed on the support element (51') and forming respective transverse portions (65'; 66') that are disposed on opposite sides of the micro-mirror (52) with respect to the axis of rotation defined by the twisting arms (68') so as to bring about the rotation of the micro-mirror as a result of electrical currents passing through the micro-mirror (52) and through the transverse portions (65'; 66') of the control tracks (61'; 62').
- 13. A device according to Claim 10 or Claim 11, in which the electromagnetic control means comprise a conductive winding (61") wound around the support element (51"), the micromirror being made of ferromagnetic material, so that the rotation of the micro-mirror (52) is brought about by a magnetic field produced by a current flowing through the winding (61").
- 14. A method of determining the internal impression of the auditory canal, characterized in that an apparatus according to any one of Claims 1 to 3 is used.
- 15. A method for the manufacture of internal hearing prostheses, characterized in that it comprises the following steps:

- determination of an internal impression of the auditory canal by means of an apparatus according to any one of Claims 1 to 3 in a manner such as to produce a three-dimensional computer representation, and
- machine production of a piece of hearing prosthesis, under the control of a computer using the data relating to the three-dimensional representation.

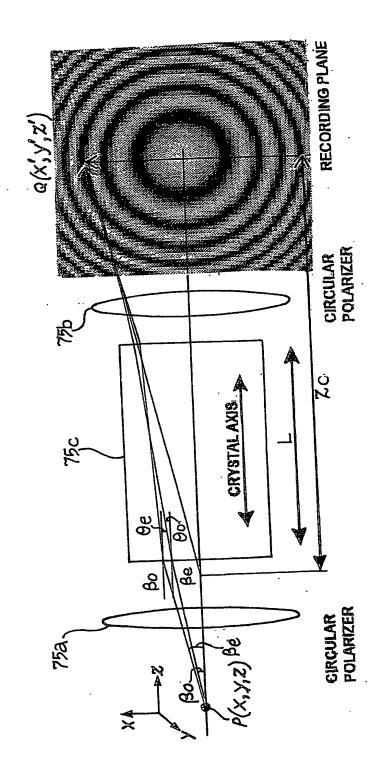


SUBSTITUTE SHEET (RULE 26)

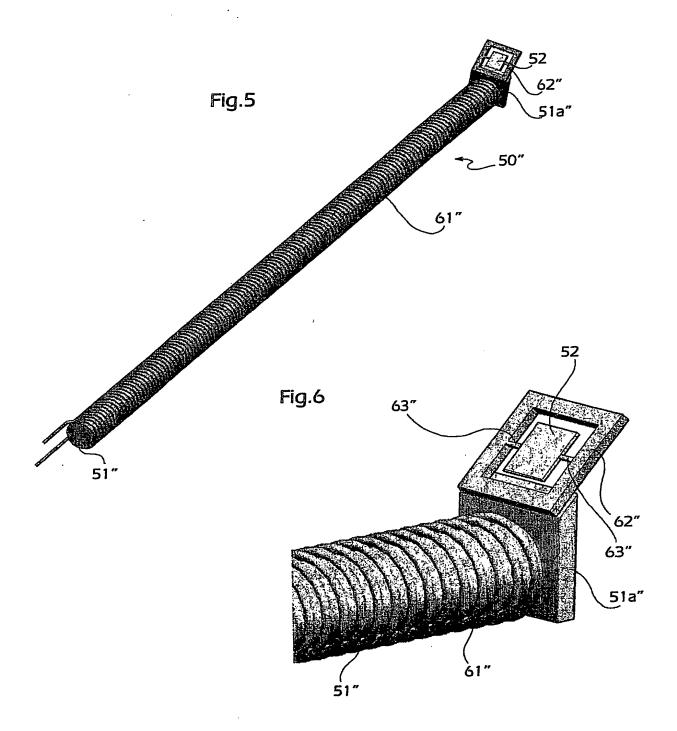
F16.3



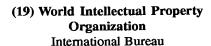
F16.4



SUBSTITUTE SHEET (RULE 26)



SUBSTITUTE SHEET (RULE 26)







(43) International Publication Date 24 December 2003 (24.12.2003)

PCT

(10) International Publication Number WO 2003/105685 A3

(51) International Patent Classification⁷: G02B 23/24, 26/08, 7/182, A61B 5/107 G01B 11/24,

(21) International Application Number:

PCT/IT2003/000366

(22) International Filing Date:

12 June 2003 (12.06.2003)

(25) Filing Language:

Italian

(26) Publication Language:

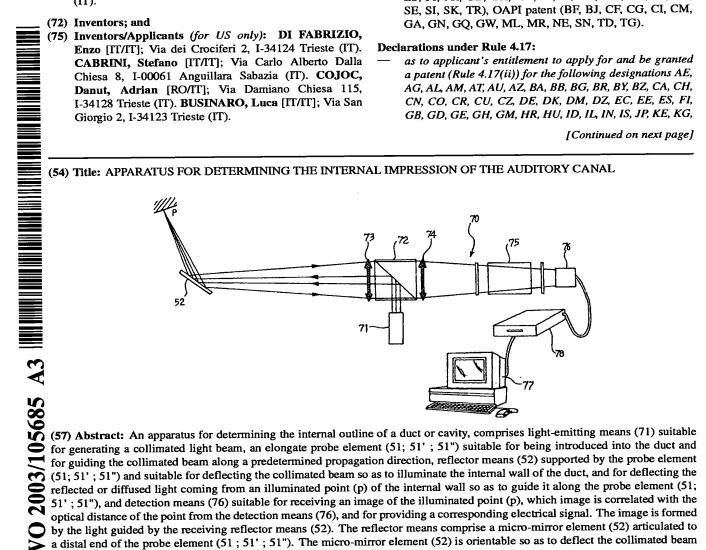
English

(30) Priority Data: TO2002A000515

14 June 2002 (14.06.2002)

- (71) Applicant (for all designated States except US): INFM IS-TITUTO NAZIONALE PER LA FISICA DELLA MA-TERIA [IT/IT]; Cordo F. Perrone, 24, I-16152 Genova
- (72) Inventors; and

- (74) Agents: RAMBELLI, Paolo et al.; Jacobacci & Partners SpA, Corso Regio Parco, 27, I-10152 Torino (IT).
- (81) Designated States (national): AE, AG, AL, AM, AT, AU, AZ, BA, BB, BG, BR, BY, BZ, CA, CH, CN, CO, CR, CU, CZ, DE, DK, DM, DZ, EC, EE, ES, FI, GB, GD, GE, GH, GM, HR, HU, ID, IL, IN, IS, JP, KE, KG, KP, KR, KZ, LC, LK, LR, LS, LT, LU, LV, MA, MD, MG, MK, MN, MW, MX, MZ, NI, NO, NZ, OM, PH, PL, PT, RO, RU, SC, SD, SE, SG, SK, SL, TJ, TM, TN, TR, TT, TZ, UA, UG, US, UZ, VC, VN, YU, ZA, ZM, ZW.
- (84) Designated States (regional): ARIPO patent (GH, GM, KE, LS, MW, MZ, SD, SL, SZ, TZ, UG, ZM, ZW), Eurasian patent (AM, AZ, BY, KG, KZ, MD, RU, TJ, TM), European patent (AT, BE, BG, CH, CY, CZ, DE, DK, EE, ES, FI, FR, GB, GR, HU, IE, IT, LU, MC, NL, PT, RO, SE, SI, SK, TR), OAPI patent (BF, BJ, CF, CG, CI, CM, GA, GN, GQ, GW, ML, MR, NE, SN, TD, TG).



by the light guided by the receiving reflector means (52). The reflector means comprise a micro-mirror element (52) articulated to a distal end of the probe element (51; 51'; 51"). The micro-mirror element (52) is orientable so as to deflect the collimated beam in selectively different directions.





KP, KR, KZ, LC, LK, LR, LS, LT, LU, LV, MA, MD, MG, MK, MN, MW, MX, MZ, NI, NO, NZ, OM, PH, PL, PT, RO, RU, SC, SD, SE, SG, SK, SL, TJ, TM, TN, TR, TT, TZ, UA, UG, UZ, VC, VN, YU, ZA, ZM, ZW, ARIPO patent (GH, GM, KE, LS, MW, MZ, SD, SL, SZ, TZ, UG, ZM, ZW), Eurasian patent (AM, AZ, BY, KG, KZ, MD, RU, TJ, TM), European patent (AT, BE, BG, CH, CY, CZ, DE, DK, EE, ES, FI, FR, GB, GR, HU, IE, IT, LU, MC, NL, PT, RO, SE, SI, SK, TR), OAPI patent (BF, BJ, CF, CG, CI, CM, GA, GN, GQ, GW, ML, MR, NE, SN, TD, TG)

— of inventorship (Rule 4.17(iv)) for US only

Published:

- with international search report
- before the expiration of the time limit for amending the claims and to be republished in the event of receipt of amendments

(88) Date of publication of the international search report: 4 March 2004

For two-letter codes and other abbreviations, refer to the "Guidance Notes on Codes and Abbreviations" appearing at the beginning of each regular issue of the PCT Gazette.





a. classification of subject matter IPC 7 G01B11/24 G02B23/24

G02B26/08

G02B7/182

A61B5/107

According to International Patent Classification (IPC) or to both national classification and IPC

B. FIELDS SEARCHED

Minimum documentation searched (classification system followed by classification symbols) I PC $\,7\,$ G02B G01B A61B

Documentation searched other than minimum documentation to the extent that such documents are included in the fields searched

Electronic data base consulted during the international search (name of data base and, where practical, search terms used)

EPO-Internal, INSPEC, PAJ, WPI Data

Category °	Citation of document, with Indication, where appropriate, of the relevant passages	Relevant to claim No.	
x	HUIKAI XIE ET AL: "A SCS CMOS micromirror for optical coherence tomographic imaging" TECHNICAL DIGEST. MEMS 2002 IEEE INTERNATIONAL CONFERENCE ON MICRO ELECTRO MECHNICAL SYSTEMS, LAS VEGAS, NV, USA, 20 January 2002 (2002-01-20), - 24 January 2002 (2002-01-24) pages 495-498, XP010577701 Piscataway, NJ, USA	1,4	
A	ISBN: 0-7803-7185-2 page 497 - 498, section "OCT application" abstract; figure 6	2,3,5-9	
A	BE 1 010 200 A (VARIPHONE BENELUX NAAMLOZE VEN) 3 March 1998 (1998-03-03) page 4, line 1 - line 9 page 6, line 17 - page 7, line 14	1,2,4, 14,15	
X Fur	her documents are listed in the continuation of box C.	re listed in annex.	

X Further documents are listed in the continuation of box C.	Patent family members are listed in annex.
 Special categories of cited documents: "A" document defining the general state of the art which is not considered to be of particular relevance "E" earlier document but published on or after the international filing date "L" document which may throw doubts on priority claim(s) or which is cited to establish the publication date of another citation or other special reason (as specified) "O" document referring to an oral disclosure, use, exhibition or other means "P" document published prior to the international filing date but later than the priority date claimed 	"T" later document published after the international filing date or priority date and not in conflict with the application but cited to understand the principle or theory underlying the invention "X" document of particular relevance; the claimed invention cannot be considered novel or cannot be considered to involve an inventive step when the document is taken alone "Y" document of particular relevance; the claimed invention cannot be considered to involve an inventive step when the document is combined with one or more other such documents, such combination being obvious to a person skilled in the art. "8" document member of the same patent family
Date of the actual completion of the international search 22 September 2003	Date of mailing of the international search report
Name and mailing address of the ISA European Patent Office, P.B. 5818 Patentlaan 2 NL - 2280 HV Rijswijk Tel. (+31-70) 340-2040, Tx. 31 651 epo nl, Fax: (+31-70) 340-3016	Authorized officer Knüpling, M



Inter 1 Apple n No
PCT) T 03/00366

	A CANDIDERED TO BE BEI EVANT	101/-11 03/0000
	ation) DOCUMENTS CONSIDERED TO BE RELEVANT	Relevant to claim No.
Category °	Citation of document, with indication, where appropriate, of the relevant passages	
A	US 2002/050744 A1 (WAELTI MARC ET AL) 2 May 2002 (2002-05-02) figure 2	1,4,6,7
Α	US 2001/022682 A1 (MCCLELLAND ROBERT WILLIAM ET AL) 20 September 2001 (2001-09-20) paragraphs [0074] - [0076]	1,4,8





INTERNATIONAL SEARCH REPORT

Box I Observations where certain claims were found unsearchable (Continuation of item 1 of first sheet)	:
This International Search Report has not been established in respect of certain claims under Article 17(2)(a) for the following reasons:	
Claims Nos.: because they relate to subject matter not required to be searched by this Authority, namely:	
Claims Nos.: because they relate to parts of the International Application that do not comply with the prescribed requirements to such an extent that no meaningful International Search can be carried out, specifically:	
3. Claims Nos.: because they are dependent claims and are not drafted in accordance with the second and third sentences of Rule 6.4(a).	
Box II Observations where unity of invention is lacking (Continuation of item 2 of first sheet)	
This International Searching Authority found multiple inventions in this international application, as follows:	
see additional sheet	
As all required additional search fees were timely paid by the applicant, this International Search Report covers all searchable claims.	
2. As all searchable claims could be searched without effort justifying an additional fee, this Authority did not invite payment of any additional fee.	
3. As only some of the required additional search fees were timely paid by the applicant, this International Search Report covers only those claims for which fees were paid, specifically claims Nos.:	
4. No required additional search fees were timely paid by the applicant. Consequently, this International Search Report is restricted to the invention first mentioned in the claims; it is covered by claims Nos.: 1-9, 14, 15	
Remark on Protest The additional search fees were accompanied by the applicant's protest. No protest accompanied the payment of additional search fees.	

FURTHER INFORMATION CONTINUED FROM PCT/ISA/ 210

This International Searching Authority found multiple (groups of) inventions in this international application, as follows:

1. claims: 1-9,14,15

Apparatus having drive unit for moving probe element

1.1. claims: 4-9

Probe having lever and control rod

1.2. claims: 14,15

Method of determinig internal impression of the auditory canal

2. claims: 10-13

Micromirror comprising twisting arms and self-supporting metallic film





PCT/IT 03/00366

Patent document cited in search report		Publication date		Patent family member(s)	Publication date
BE 1010200	Ä	03-03-1998	BE	1010200 A3	03-03-1998
US 2002050744	A1	02-05-2002	AU GB WO	8674501 A 2384060 A 0218979 A2	13-03-2002 16-07-2003 07-03-2002
US 2001022682	A1	20-09-2001	US US	6201629 B1 2001021058 A1	13-03-2001 13-09-2001

CORRECTED VERSION

(19) World Intellectual Property Organization

International Bureau



(43) International Publication Date 24 December 2003 (24.12.2003)

PCT

(10) International Publication Number WO 2003/105685 A3

(51) International Patent Classification7: G02B 23/24, 26/08, 7/182, A61B 5/107 G01B 11/24.

(21) International Application Number:

PCT/IT2003/000366

12 June 2003 (12.06.2003) (22) International Filing Date:

(25) Filing Language:

Italian

(26) Publication Language:

TO2002A000515

English

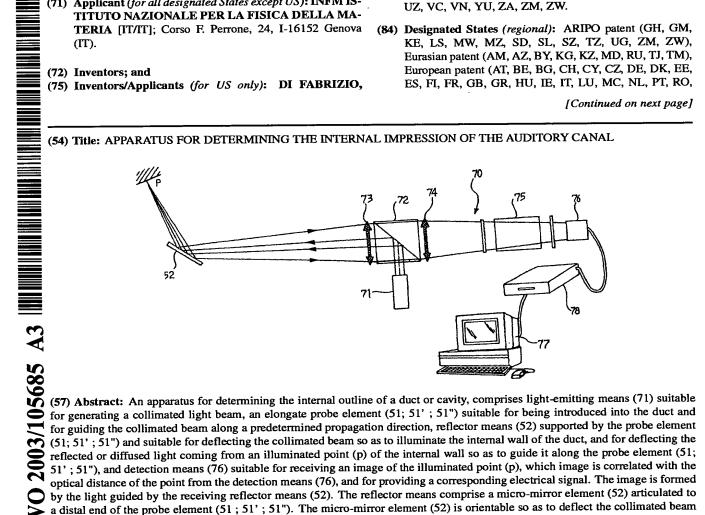
(30) Priority Data:

14 June 2002 (14.06.2002)

(71) Applicant (for all designated States except US): INFM IS-TITUTO NAZIONALE PER LA FISICA DELLA MA-

Enzo [IT/IT]; Via dei Crociferi 2, I-34124 Trieste (IT). CABRINI, Stefano [IT/IT]; Via Carlo Alberto Dalla Chiesa 8, I-00061 Anguillara Sabazia (IT). COJOC, Danut, Adrian [RO/IT]; Via Damiano Chiesa 115, I-34128 Trieste (IT). BUSINARO, Luca [IT/IT]; Via San Giorgio 2, I-34123 Trieste (IT).

- (74) Agents: RAMBELLI, Paolo et al.; Jacobacci & Partners SpA, Corso Regio Parco, 27, I-10152 Torino (IT).
- (81) Designated States (national): AE, AG, AL, AM, AT, AU, AZ, BA, BB, BG, BR, BY, BZ, CA, CH, CN, CO, CR, CU, CZ, DE, DK, DM, DZ, EC, EE, ES, FI, GB, GD, GE, GH, GM, HR, HU, ID, IL, IN, IS, JP, KE, KG, KP, KR, KZ, LC, LK, LR, LS, LT, LU, LV, MA, MD, MG, MK, MN, MW, MX, MZ, NI, NO, NZ, OM, PH, PL, PT, RO, RU, SC, SD, SE, SG, SK, SL, TJ, TM, TN, TR, TT, TZ, UA, UG, US, UZ, VC, VN, YU, ZA, ZM, ZW.
- (84) Designated States (regional): ARIPO patent (GH, GM,



by the light guided by the receiving reflector means (52). The reflector means comprise a micro-mirror element (52) articulated to a distal end of the probe element (51; 51'; 51"). The micro-mirror element (52) is orientable so as to deflect the collimated beam in selectively different directions.





SE, SI, SK, TR), OAPI patent (BF, BJ, CF, CG, CI, CM, GA, GN, GQ, GW, ML, MR, NE, SN, TD, TG).

Declarations under Rule 4.17:

as to applicant's entitlement to apply for and be granted a patent (Rule 4.17(ii)) for the following designations AE, AG, AL, AM, AT, AU, AZ, BA, BB, BG, BR, BY, BZ, CA, CH, CN, CO, CR, CU, CZ, DE, DK, DM, DZ, EC, EE, ES, FI, GB, GD, GE, GH, GM, HR, HU, ID, IL, IN, IS, JP, KE, KG, KP, KR, KZ, LC, LK, LR, LS, LT, LU, LV, MA, MD, MG, MK, MN, MW, MX, MZ, NI, NO, NZ, OM, PH, PL, PT, RO, RU, SC, SD, SE, SG, SK, SL, TJ, TM, TN, TR, TT, TZ, UA, UG, UZ, VC, VN, YU, ZA, ZM, ZW, ARIPO patent (GH, GM, KE, LS, MW, MZ, SD, SL, SZ, TZ, UG, ZM, ZW), Eurasian patent (AM, AZ, BY, KG, KZ, MD, RU, TJ, TM), European patent (AT, BE, BG, CH, CY, CZ, DE, DK, EE, ES, FI, FR, GB, GR, HU, IE, IT, LU, MC, NL, PT, RO, SE, SI, SK, TR), OAPI patent (BF, BJ, CF, CG, CI, CM, GA, GN, GQ, GW, ML, MR, NE, SN, TD, TG)

of inventorship (Rule 4.17(iv)) for US only

Published:

- with international search report
- (88) Date of publication of the international search report:
 4 March 2004
- (48) Date of publication of this corrected version: 27 May 2004
- (15) Information about Correction: see PCT Gazette No. 22/2004 of 27 May 2004, Section II

For two-letter codes and other abbreviations, refer to the "Guidance Notes on Codes and Abbreviations" appearing at the beginning of each regular issue of the PCT Gazette.